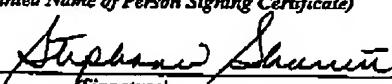


CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8)			
Applicant(s): Palash P. Das, et al.		Docket No. 2003-0105-02	
Application No. 10/781,251	Filing Date 2/18/04	Examiner Unassigned	Group Art Unit Unassigned
Invention: VERY HIGH ENERGY, HIGH STABILITY GAS DISCHARGE LASER SURFACE TREATMENT			
<i>48 Pages total</i>			
<p>I hereby certify that this <u>Information Disclosure Statement & PTO 1449 & 5 references</u> (Identify type of correspondence) is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. <u>703-872-9306</u></p>			
on <u>June 14, 2004</u> (Date)			
<u>Stephanie Sharrett</u> (Typed or Printed Name of Person Signing Certificate)  (Signature)			
<p>Note: Each paper must have its own certificate of mailing.</p>			

USSN 10/781,251

Attorney Docket No. 2003-0105-02

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Stephanie Sharrett

(Typed or Printed Name of Person mailing papers or fees)

Stephanie Sharrett

(Signature of Person mailing papers or fees)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re Application of:

Palash P. Das, et al.

Serial No.: 10/781,251

Filing Date: February 18, 2004

Title: VERY HIGH ENERGY, HIGH
STABILITY GAS DISCHARGE LASER
SURFACE TREATMENT SYSTEM

Examiner: Unassigned

JUN 14 2004

Group Art Unit: Unassigned

OPTIONAL
CANCELLATION

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In accordance with 37 C.F.R. § 1.97 and § 1.98, applicants submit for consideration in the above-identified application the attached Form PTO-1449. The Information Disclosure Statement submitted herewith is being filed before the mailing date of the first Office Action on the merits. Copies of the cited references are not provided pursuant to the USPTO waiving the requirement of submitting patent copies for applications filed after June 30, 2003, however Items AZ through BD are provided herewith.

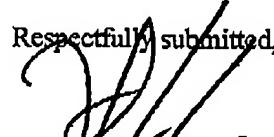
It is respectfully requested that the Examiner indicate consideration of the cited references by returning a copy of the attached form PTO-1449 with initials or other appropriate marks.

USSN 10/781,251
Attorney Docket No. 2003-0105-02

This Information Disclosure Statement under 37 C.F.R. § 1.97 is not to be construed as a representation that: (i) a complete search has been made; (ii) additional information material to the examination of this application does not exist; (iii) the information, protocols, results and the like reported by third parties are accurate or enabling; or (iv) the above information constitutes prior art to the subject invention.

Accordingly, no fee is believed to be due. The Commissioner is hereby authorized to charge any fees, or to credit any overpayment to Deposit Account No. 03-4060.

Respectfully submitted,



William Cray; Reg. No. 27,627

June 14, 2004
Cymer, Inc.
Legal Department - MS/4-2C
17075 Thorntint Court
San Diego, California 92127-1712
Telephone: 858-385-7185
Facsimile: 858-385-6025

U.S. Department of Commerce, Patent and Trademark Office				Atty Docket No.	Serial No.		
				2003-0105-02	10/781,251		
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)				Applicant(s)			
				Palash Das, et al.			
				Filing Date	Group		
				February 18, 2004	Unassigned		
U.S. Patent Documents							
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
A	4,223,279	9/16/80	Bradford, Jr., et al.	331	94.5		
B	4,455,658	6/19/84	Sutter, et al.	372	38		
C	4,618,759	10/21/86	Muller, et al.	219	121		
D	4,959,840	9/25/90	Robert Akins, et al.	372	57		
E	5,023,884	6/11/91	Robert Akins, et al.	372	57		
F	5,025,445	6/18/91	Anderson, et al.	372	20		
G	5,025,446	6/18/91	Dirk J. Kuizenga	372	21		
H	5,189,678	2/23/93	Ball, et al.	372	28		
I	5,313,481	5/17/94	Cook, et al.	372	37		
J	5,315,611	5/24/94	Ball, et al.	372	56		
K	5,359,620	10/25/94	Robert Akins	372	58		
L	5,448,580	9/5/95	Birx, et al.	372	38		
M	5,471,965	12/5/95	Davorin D. Kapich	123	565		
N	5,852,621	12/22/98	Richard L. Sandstrom	372	25		
O	5,863,017	1/26/99	Larson, et al.	248	176.1		
P	5,953,360	9/14/99	Vitruk, et al.	372	87		
Q	5,978,394	11/2/99	Newman, et al.	372	32		
R	5,991,324	11/23/99	Knowles, et al.	372	57		
S	6,005,879	12/21/99	Sandstrom, et al.	372	25		
T	6,016,325	1/18/00	Ness, et al.	372	38		
Foreign Patent Documents							
						Translation	
	Document	Date	Country	Class	Subclass	Yes	No
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)							
Examiner	Date Considered						
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.							

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(Use several sheets if necessary)				Palash Das, et al.				
				Filing Date	Group			
				February 18, 2004	Unassigned			
U.S. Patent Documents								
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate		
U	6,018,537	1/25/00	Hofmann, et al.	372	25			
V	6,028,880	2/22/00	Carlesi, et al.	372	58			
W	6,067,306	5/23/00	Sandstrom, et al.	372	38			
X	6,067,311	5/23/00	Morton, et al.	372	57			
Y	6,094,448	7/25/00	Fomenkov, et al.	372	102			
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AD	6,164,116	12/26/00	Rice, et al.	73	1.72			
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AG	6,208,675	3/27/01	R. Kyle Webb	372	58			
AH	6,212,211	4/3/01	Azzola, et al.	372	33			
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AJ	6,240,117	5/29/01	Gong, et al.	372	58			
AK	6,317,447	11/13/01	Partlo, et al.	372	57			
AL	6,330,261	12/11/01	Ishihara, et al.	372	38.1			
AM	6,414,979	7/2/02	Ujazdowski, et al.	372	87			
AN	6,477,193	11/5/02	Oliver, et al.	372	58			
AO	6,549,551	4/15/03	Ness, et al.	372	38			
AP	6,567,450	5/20/03	Myers, et al.	372	55			
Foreign Patent Documents								
							Translation	
	Document	Date	Country	Class	Subclass		Yes	No
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Examiner		Date Considered						
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)		Applicant(s)	
		Palash Das, et al.	
		Filing Date	Group
		February 18, 2004	Unassigned

U.S. Patent Documents

*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
AQ	6,618,421	9/9/03	Das, et al.	372	55	
AR	6,625,191	9/23/03	Knowles, et al.	372	55	
AS	09/451,995	11/30/99	Hofmann, et al.			
AT	10/606,412	6/25/03	Saethre, et al.			
AU	10/607,407	6/25/03	Ness, et al.			
AV	10/712,545	11/13/03	R. Kyle Webb, et al.			
AW	2002/0021728	2/21/02	Newman, et al.	372	55	
AX	2002/0167986	11/14/02	Pan, et al.	372	55	
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AY	2004/0022293	2/5/04	Rule, et al.	372	58	

Foreign Patent Documents

							Translation	
	Document	Date	Country	Class	Subclass		Yes	No

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

Az	Dassow, et al., "YVO ₄ Laser Crystallization for Thin Film Transistors with a High Mobility," Mat. Res. Soc. Symp., Proc. Vol. 621, pp. 9.3.1-9.3.6, (2000).
BA	Kudo, et al., "Advanced Lateral Crystal Growth of a Si Thin Films by Double-Pulsed Irradiation of All Solid-State Lasers," Mat. Res. Soc. Symp. Proc. Vol. 762, pp. A16.5.1-6, (2003).
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BD	Yres, J., et al., "Low Temperature Poly-Si for Liquid Crystal Display Addressing," Philips Research Laboratories, Surrey, England, (May 11 1993); http://www.atip.org/ATIP/public/atip.reports.93/mits-lcd.93.html

Examiner	Date Considered
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